

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Appln. Of: SAMUKAWA et al. Art Unit: 1763
Serial No.: 10/501,351 EXAMINER: Dhingra, Rakesh Kumar
Filed: July 14, 2004
For: On-Wafer Monitoring System
DOCKET: SHIG CPTA0502FE Confirmation No. 7535

MAIL STOP ISSUE FEE
Commissioner of Patents
PO BOX 1450
Alexandria, VA 22313-1450

SUBMISSION OF CORRECTED FORMAL DRAWINGS

Dear Sir:

In response to the Notice of Drawing Inconsistency with Specification mailed January 30, 2009, submitted herewith one (1) Replacement sheet of a corrected formal drawing with respect to the above-identified patent application.

In the event there are any fee deficiencies or additional fees are payable, please charge them (or credit any overpayment) to our Deposit Account No. 08-1391.

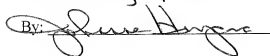
Respectfully submitted,



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CERTIFICATE OF ELECTRONIC FILING

I hereby certify that this correspondence is being deposited with the United States Patent Office via the electronic filing procedure on February 6, 2009.

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